

**Notice of References Cited**

Application/Control No.

09/810,828

Applicant(s)/Patent Under  
Reexamination  
ZARRABIAN ET AL.

Examiner

Thomas R Artman

Art Unit

2882

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*		Document Number	Date	Name	Classification
		Country Code-Number-Kind Code	MM-YYYY		
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## NON-PATENT DOCUMENTS

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.